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PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): James E. Moon, et al.

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Art Unit: 1763

Filed: November 02, 2001

Examiner: Olsen, Allan W.

Title: **METHOD FOR FABRICATING MEMS AND  
MICROFLUIDIC DEVICES USING LATENT MASKING TECHNIQUE**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail addressed to Mail Stop, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 19, 2003.

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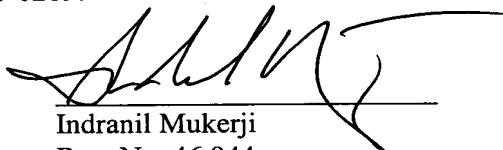
**NOTICE OF LOSS OF  
ENTITLEMENT TO SMALL ENTITY STATUS**

Sir:

Pursuant to 37 C.F.R. § 1.27(g)(2), Applicants hereby notify the U.S. Patent and Trademark Office that they no longer claim small entity status, and respectfully request that small entity status be removed with regard to the patent application identified above.

While no fee is believed due with this submission, the Commissioner is hereby authorized to charge any additional fees associated with this submission, or credit any overpayment, to Deposit Account No. 50-0289.

Dated: 8.19.03



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